

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

KOBAYASHI, *et al.*

Serial No.: 10/585,994

Filed: 13 July 2006

For: MANUFACTURING METHOD OF SEMICONDUCTOR  
DEVICE AND FILM DEPOSITION SYSTEM

**Confirmation No. 8859**

Art Unit: 2823

Examiner: Kevin A. Parendo

Atty. Dckt: 033082M336

**PETITION FOR A THREE-MONTH EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is a Petition for an Extension of Time for a three month period. This Petition for Extension of Time is being concurrently filed with a Response.

Payment of the requisite fee is being made with a credit card using EFS-Web.

Respectfully submitted,  
SMITH, GAMBRELL & RUSSELL, LLP



Michael A. Makuch  
Reg. No. 32,263

Date: July 20, 2009

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